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Bib Data Sheet

CONFIRMATION NO. 2057

<b>SERIAL NUMBER</b> 09/937,538	<b>FILING DATE</b> 09/25/2001 <b>RULE</b>	<b>CLASS</b> 073	<b>GROUP ART UNIT</b> 2856	<b>ATTORNEY DOCKET NO.</b> 81839.0102
<b>APPLICANTS</b> Michihiro Mizuno, Fukushima, JAPAN;				
<b>** CONTINUING DATA *****</b> THIS APPLICATION IS A 371 OF PCT/JP01/00301 01/18/2001				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-16517 01/26/2000				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 2	<b>TOTAL CLAIMS</b> 18
Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>INDEPENDENT CLAIMS</b> 1		
<b>ADDRESS</b> 26021				
<b>TITLE</b> Method for evaluating concentration of metallic impurities in silicon wafer				
<b>FILING FEE RECEIVED</b> 860	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	